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Correction: Recent progress in controlled nano/micro cracking as an alternative nano-patterning method for functional applications

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Correction for 'Recent progress in controlled nano/micro cracking as an alternative nano-patterning method for functional applications' by Jinwook Jung *et al.*, *Nanoscale Horiz.*, 2020, DOI: 10.1039/D0NH00241K.

The authors of this article have noticed that incorrect affiliations were listed for Sukjoon Hong and Junyeob Yeo in the originally published article.

The correct affiliation for Sukjoon Hong is as follows:

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The Royal Society of Chemistry apologises for these errors and any consequent inconvenience to authors and readers.

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